

GATEKEEPER® OPTICS GAS PURIFIERS

Cost-effective, environmentally friendly gas purification



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Overview

Available for low and high-flow applications, GateKeeper® optics gas purifiers are designed for use with CDA (air) and remove $\rm H_2O$, volatile bases, volatile acids, condensable organics and refractory compounds to ppt (parts-pertrillion) levels.

Features and Benefits

Cost-effective

- Regenerable for low cost of ownership
- Gas purification improves process consistency, increases product yields and lengthens tool life
- Transforms low-purity gas into UHP grade, reducing process costs

Environmentally Friendly

• Regenerable – eliminates disposal issues

Process Protection

- Consistently delivers ultrapure gas
- Guards against bulk gas purifier break-through, impurity spikes from liquid storage tanks, cylinder changeouts and unexpected contaminants in the process
- Does not release hydrocarbons that may contaminate the process
- Low pressure drop across purifiers
- CE certified to the Pressure Equipment Directive (PED) and manufactured in an ISO 9001:2000 facility
- Backed by global service and support staff

Safe and Simple to Use

- Easy to install
- Uses ambient temperature purification technology no power or heat required
- No moving parts

General Specifications

316L stainless steel, electropolished 10 Ra			
CDA (Clean Dry Air), nitrogen and noble gases			
$<\!100$ ppt $\rm H_2O$; $<\!10$ ppt volatile bases; $<\!1$ ppt volatile acids, condensable organics and refractory compounds			
70KF to 10MH	0.003 μm 316L stainless steel		
200M 20 μm	316L stainless steel		
Inorganic			
1379 kPa (200 psid)			
101 kPa (14.7 psia)			
70KF to 10M	1 × 10 ⁻⁹ atm cc/sec		
200M	4 × 10 ⁻⁹ atm cc/sec		
10 ppm (parts-per-million)			
One year at nominal flow rate with 1 ppm inlet challenge of moisture			
65°C (149°F)			
	CDA (Clean Dry Air) <100 ppt H ₂ O; <10 and refractory comp 70KF to 10MH 200M 20 µm Inorganic 1379 kPa (200 psid) 101 kPa (14.7 psia) 70KF to 10M 200M 10 ppm (parts-per-		

Operating Specifications

Model	Maximum Flow Rate (SLPM)	Nominal Flow Rate (SLPM)	Maximum Operating Pressure Purifier Only ¹	Maximum Operating Pressure Purifier with Options ²	Pressure Drop ³		
70KF	3	2.3	19995 kPa (2900 psig)	1724 kPa (250 psig)	4.8 kPa (0.7 psid)		
300KF	50	13.8	4826 kPa (700 psig)	1724 kPa (250 psig)	34.5 kPa (5 psid)		
500KF	60	27	4826 kPa (700 psig)	1724 kPa (250 psig)	48.3 kPa (7 psid)		
700KF	120	36	4826 kPa (700 psig)	1724 kPa (250 psig)	48.3 kPa (7 psid)		
2500KH	500	135	1724 kPa (250 psig)	1724 kPa (250 psig)	27.6 kPa (2.5 psid)		
10MH	1000 1000	480 480	1724 kPa (250 psig) 1724 kPa (250 psig)	1724 kPa (250 psig) 1724 kPa (250 psig)	¹ /2" – 62 kPa (9 psid) ³ /4" – 36.5 kPa (5.3 psid)		
200MZ ^{4,5}	20000	3500	1379 kPa (200 psig)	1379 kPa (200 psig)	27.6 kPa (4 psid)		
Drop-in Replacements for Waferpure® Purifiers							
75KF (Mini-XL)	5	2.3	19995 kPa (2900 psig)	1724 kPa (250 psig)	10.3 kPa (1.5 psid)		
300KF (Megaline)	50	13.8	4826 kPa (700 psig)	1724 kPa (250 psig)	34.5 kPa (5 psid)		

¹ Do not use under vacuum. Minimum pressure should be 1 atm (14.7 PSIA). ² Pressure limited by standard valves, higher pressures available; please consult your local sales representative. ³ Pressure drop at maximum flow rate and 90 psig (620 kPa) inlet pressure. For a detailed pressure drop curve and other pressures or flows, please consult your local sales representative or visit www.entegris.com. ⁴ This product uses "Z" media; the removal specifications are identical to the "O" media. ⁵ Model only available for countries that recognize ASTM US standards; not currently CE certified; contact Entegris if needed for EU application. All product information is subject to change without notice.

Facility Specifications

Model	Fitting Sizes	Configuration (inlet/outlet)	Approximate Weight	Length	Diameter	Fitting Offset
70KF	1/4" face seal	male/male	0.4 kg (0.88 lb)	11.4 cm (4.5")	3.8 cm (1.5")	Centered
300KF	1/4" face seal	male/male	1.8 kg (4 lb)	20.8 cm (8.2")	5.1 cm (2")	Centered
500KF	1/4" face seal	male/male	1.6 kg (3.5 lb)	20.2 cm (7.94")	7.6 cm (3")	Centered
700KF	1/4" face seal	male/male	1.6 kg (3.5 lb)	25.4 cm (10")	7.6 cm (3")	Centered
2500KH	1/4" face seal 1/2" face seal	male/male male/male	9.5 kg (20.9 lb) 9.5 kg (20.9 lb)	43.9 cm (17.3") 44.7 cm (17.6")	10.2 cm (4") 10.2 cm (4")	Centered Centered
10MH	1/2" face seal 3/4" face seal	female/male female/female	27 kg (59.5 lb) 41 kg (90.3 lb)	97.4 cm (38.36") 143.3 cm (56.4")	15.2 cm (6") 15.2 cm (6")	Centered Centered
200MZ	2" tube stub	_	454 kg (1000 lb)	165.9 cm (65.3") ⁶	111.8 cm (44") ⁷	85.9 cm (33.2") ⁸
Drop-in Replacer	nents for Wafe	rpure Purifiers				
75KF (Mini-XL)	1/4" face seal	male/male	0.4 kg (0.88 lb)	12.7 cm (5")	3.8 cm (1.5")	0.97 cm (0.38")
300KF (Megaline)	1/4" face seal	male/male	1.8 kg (4 lb)	20.8 cm (8.2")	5.1 cm (2")	Centered

⁶ Height ⁷ Depth ⁸ Width

Options

Model	Isolation Valves	GC 300 Manifold	3 Valve Bypass Manifold	5 Valve Bypass Manifold	4 Valve Changeover Manifold ⁹	8 Valve Changeover Manifold ¹⁰	Moisture Breakthrough Indicator ¹¹
70KF	Yes		Yes				Yes
300KF	Yes	Yes					Yes
500KF	Yes		Yes	Yes			Yes
700KF	Yes						Yes
2500KH	Yes		Yes	Yes		Yes	Yes
10MH	included		Yes		Yes		Yes
200MZ	included						
Drop-in Replacen	nents for Wa	ferpure Puri	fiers				
75KF (Mini-XL)	Yes						Yes
300KF (Megaline)	Yes	Yes					Yes

Ordering Information

GateKeeper Gas Purifiers Part Number CE* **Additional Processing** R= Regeneration **Fitting** $4R = \frac{1}{4}$ " face seal male-to-male **Gas Series** $8R = \frac{1}{2}$ " face seal male-to-male C = Corrosive 8Y = 1/2" face seal female-to-male Filter H = Hydrogen $12W = \frac{3}{4}$ " face seal female-to-female $F=0.003\;\mu m$ I = Inert Model $H = 0.003 \ \mu m$ N = Nonreactive 70K (low pressure 0 = OpticsExample: CE2500KH08RR 300K drop) SK = Hydride Model = 2500K500K LK = Carbon monoxide Filter = $0.003 \mu m$ (low pressure drop) 700K Gas series = Optics 2500K Fitting = 1/2" face seal male-to-male 10M Additional processing = Regeneration

Note: Not all models are available with all gas series, fittings or additional processing; contact your salesperson for more information.

Note: If you have an older Mykrolis® Micro or Mini-XL purifier, specify drop-in replacement 300K or 75K.

For detailed product information including dimensional drawings, pressure drop curves, safety information and for help selecting a purifier and determining purifier lifetimes, please visit our website at *www.entegris.com*. Go to Products> Purification>Gas Purification

All products with the exception of model 200M meet CE Directive 97/23/EC requirements.





Contact Customer Service to learn about our regeneration service.

For More Information

Please call your Regional Customer Service Center today to learn what Entegris can do for you. Visit *www.entegris.com* and select the Customer Service link for the center nearest you.

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All purchases are subject to Entegris' Terms and Conditions of Sale. To view and print this information, visit *www.entegris.com* and select the Legal Notices link from the footer.

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ENTEGRIS, INC.

Corporate Headquarters | 129 Concord Road | Billerica, MA 01821 USA Customer Service Tel. +1 952 556 4181 | Customer Service Fax +1 952 556 8022 In North America 800 394 4083 | www.entegris.com



^{*} For all models except 200M. To order 200M: SS200MZ